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U.S. PATENT DOCUMENTS

Examiner Initial		Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
<i>JA</i>	AA	5,731,079	Hammond et al.	03/24/98			
	AB						

FOREIGN PATENT DOCUMENTS

		Document No.	Date	Country	Translation (Yes or No)
<i>JA</i>	AC	0 166 349 A1	✓ 01/02/86	EPO	Yes. See PCT search report.
<i>JA</i>	AD	0 685 439 A2	✓ 12/06/95	EPO	Yes. See PCT search report.

OTHER DOCUMENTS

<i>JA</i>	AE	Münz et al.; Journal of Vacuum Science & Technology, Vol.4, No. 6, pp. 2717-2752, Nov. 1986. See PCT search report.
	AF	Vaz et al.; Surface & Coating Technology, Elsevier, Vol. 108-109, pp. 236-240, Oct. 1998. See PCT search report.
	AG	Sun et al.; Journal of Applied Physics, U.S. American Institute of Physics, Vol. 81, No.2, pp.656-663, Jan. 1997. See PCT search report.
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	AI	Shew et al.; Thin Solid Films, Elsevier, Vol. 293, No. 1-2, pp. 212-219, 1997. See PCT search report.
<i>JA</i>	AJ	Patent Abstract of Japan, Publication No. 05250770, Sept. 28, 1993. See PCT search rpt.
Examiner	<i>Turner</i>	Date Considered <i>8/10/02</i>